Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION
(use several sheets if necessary)

Docket No. P01,0538	Serial No. 10/071,484
Applicant D. W. Youngner	
Filing Date February 7, 2002	Group Art Unit 2873 2818

U.S. PATENT DOCUMENTS

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
OG	AA	5,808,210	09/15/98	Herb et al.			
OG	AB	5,559,358	09/24/96	Burns et al.			
OG	AC	5,959,338	09/28/99	Youngner et al.			
OG	AD	6,031,944	02/29/00	Youngner			
OG	AE	6,126,140	10/03/00	Johnson et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

OG	AT	H. Guckel et al., "Polysilicon Resonant Microbeam Technology for High Performance Sensor Applications", pgs. 153-156, 1992
OG	AU	H. Guckel et al., "Polysilicon Resonant Microbeam Technology for High Performance Sensor Applications", 2 pages, 1992
OG	AV	Burns et al., "A Digital Pressure Sensor Based on Resonant Microbeams", Solid-State Sensor and Actuator Workshop Hilton Head, South Carolina, June 13-16, 1994, pgs. 221-224.
	AW	

Examiner Olile Gah	Date Considered 05/29/03

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.